

STATEMENT UNDER 37 CFR 3.73(b)

Applicant/Patent Owner: Shinji Maekawa, Shunpei Yamazaki

Application No./Patent No.: 10/827,457

Filed/Issue Date: April 19, 2004

Titled: METHOD FOR FORMING PATTERN AND DROP DISCHARGE APPARATUS

Semiconductor Energy Laboratory Co., Ltd. , a Corporation

(Name of Assignee)

(Type of Assignee, e.g., corporation, partnership, university, government agency, etc.)

states that it is:

1. the assignee of the entire right, title, and interest in;
 2. an assignee of less than the entire right, title, and interest in
(The extent (by percentage) of its ownership interest is _____ %); or
 3. the assignee of an undivided interest in the entirety of (a complete assignment from one of the joint inventors was made) the patent application/patent identified above, by virtue of either:
- A. An assignment from the inventor(s) of the patent application/patent identified above. The assignment was recorded in the United States Patent and Trademark Office at Reel 015245, Frame 0619, or for which a copy therefore is attached.

OR

- B. A chain of title from the inventor(s), of the patent application/patent identified above, to the current assignee as follows:

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Additional documents in the chain of title are listed on a supplemental sheet(s).

As required by 37 CFR 3.73(b)(1)(i), the documentary evidence of the chain of title from the original owner to the assignee was, or concurrently is being, submitted for recordation pursuant to 37 CFR 3.11.

[NOTE: A separate copy (i.e., a true copy of the original assignment document(s)) must be submitted to Assignment Division in accordance with 37 CFR Part 3, to record the assignment in the records of the USPTO. See MPEP 302.08]

The undersigned (whose title is supplied below) is authorized to act on behalf of the assignee.

/Edward D. Manzo/

Signature

August 23, 2010

Date

Edward D. Manzo; Reg. No. 28,139

Attorney/Agent of Record

Printed or Typed Name

Title

This collection of information is required by 37 CFR 3.73(b). The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.11 and 1.14. This collection is estimated to take 12 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.



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Total Assignments: 1

Patent #: NONE **Issue Dt:** **Application #:** 10827457 **Filing Dt:** 04/19/2004
Publication #: 20050043186 **Pub Dt:** 02/24/2005

Inventors: Shinji Maekawa, Shunpei Yamazaki**Title:** Method for forming pattern and drop discharge apparatus**Assignment: 1**

Reel/Frame: 015245/0619 **Recorded:** 04/19/2004 **Pages:** 2

Conveyance: ASSIGNMENT OF ASSIGNORS INTEREST (SEE DOCUMENT FOR DETAILS).

Assignors: MAEKAWA, SHINJI **Exec Dt:** 04/12/2004

YAMAZAKI, SHUNPEI **Exec Dt:** 04/13/2004

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